TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. AZU.002	
In Re Application Of:	/ukio NARUKAWA et al.			
Serial No.	Filing Date	Examiner	Group Art Unit	
NEW	OCT. 20, 2003	TO BE ASSIGNED	TO BE ASSIGNED	
Title: NITRIDE SEMICONDUCTOR DEVICE, AND ITS FABRICATION PROCESS				
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450				
37 CFR 1.97(b)				
1. Me Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.				
37 CFR 1.97(c)				
2. The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:				
☐ the statement specified in 37 CFR 1.97(e);				
OR				
☐ the fee set forth in 37 CFR 1.17(p).				
	Σ			

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT Docket No. AZU.002 (Under 37 CFR 1.97(b) or 1.97(c)) In Re Application: 'Yukio NARUKAWA et al. Group Art Unit Examiner Serial No. Filing Date TO BE ASSIGNED TO BE ASSIGNED OCT. 20, 2003 NEW NITRIDE SEMICONDUCTOR DEVICE, AND ITS FABRICATION PROCESS Payment of Fee (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p)) is attached. A check in the amount of ☐ The Director is hereby authorized to charge and credit Deposit Account as described below. Charge the amount of Credit any overpayment. Charge any additional fee required. Certificate of Mailing by First Class Mail Certificate of Transmission by Facsimile* I certify that this document and fee is being deposited certify that this document and authorization to charge deposit with the U.S. Postal Service account is being facsimile transmitted to the United States as first class mail under 37 C.F.R. 1.8 and is Patent and Trademark Office (Fa addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. (Date) Signature of Person Mailing Correspondence Signature Typed or Printed Name of Person Mailing Certificate Typed or Printed Name of Person Signing Certificate *This certificate may only be used if paying by deposit account. Dated: OCT. 20, 2003 ADAM C. VOLENTINE REG. NO. 33289 VOLENTINE FRANCOS, PLLC 12200 SUNRISE VALLEY DRIVE, SUITE 150 RESTON VA 20191 TEL. NO. (703) 715-0870 cc:

Application Number Docket Number (Optional) NEW AZU.002

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Applicant(s) Yukio NARUKAWA et al.	
	Filing Date	Group Art Unit

TO BE ASSIGNED OCT. 20, 2003 U.S. PATENT DOCUMENTS FILING DATE EXAMINER CLASS SUBCLASS DOCUMENT NUMBER DATE NAME INITIAL IF APPROPRIATE 05/08/2001 TAKEUCHI et al. 6,229,151 FOREIGN PATENT DOCUMENTS Translation DATE COUNTRY CLASS SUBCLASS DOCUMENT NUMBER REF YES NO 12/22/1997 **JAPAN** 9-331116 ABSTRACT 2001-28458 01/30/2001 **JAPAN** C abstract OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) P. Waltereit et al., "Nitride semiconductors free of electrostatic fields for efficient white light-emitting diodes", Nature, vol. 406, 24 August 2000, pages 865-868. D DATE CONSIDERED EXAMINER

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.